

Docket No.: R2180.0159/P159
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kazunari Kimino

DO NOT ENTER: /GRK/
07/30/2009

Application No.: 10/609,634

Confirmation No.: 4954

Filed: July 1, 2003

Art Unit: 1791

For: APPARATUS AND METHOD FOR
MANUFACTURING SEMICONDUCTOR
DEVICE

Examiner: G. R. Koch

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Madam:

INTRODUCTORY COMMENTS

In response to the Office Action dated May 5, 2009, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 11 of this paper.